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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AUG 31 2005

Application of

Applicants : Er-Xuan Ping  
Serial No. : 10/732,962  
Filed : December 11, 2003  
Confrm No. : 9292  
Title : **EVEN NUCLEATION BETWEEN SILICON AND OXIDE  
SURFACES FOR THIN SILICON NITRIDE FILM GROWTH**  
Docket No. : MIO 0088 V3/40509.280  
Examiner : D. Nhu  
Art Unit : 2818

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION  
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Office ((571)273-8300) on August 31, 2005.

  
William A. Jividen

42,695  
Reg. No.

Sir:

**AMENDMENT**

This paper is being filed in response to the Office Action mailed June 28, 2005.

Reconsideration of the present application is respectfully requested in light of the amendments and remarks below, which include, in order of appearance, beginning on separate sheets:

• Amendments to the Claims; and

• Remarks.